

09/856384

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

Rec'd PCT/PTO 21 MAY 2001
Docket No.
25,096 USA

In Re Application Of: **Kiyoshi Motegi & Satoru Oshikawa**

Serial No.
N/A

Filing Date
Herewith

Examiner
N/A

Group Art Unit
N/A

Title: **OPTICAL APPARATUS, EXPOSURE APPARATUS, LASER LIGHT SOURCE, GAS SUPPLY METHOD, EXPOSURE METHOD, AND DEVICE MANUFACTURING METHOD**

Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of _____ is attached.
- ☐ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. _____ as described below. A duplicate copy of this sheet is enclosed.
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Dated: May 21, 2001

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Address to:
Assistant Commissioner for Patents
Washington, D.C. 20231

37 CFR 1.97(b)

1. ☒ The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application; within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or before the mailing date of a first Office Action on the merits, whichever event occurs last.

37 CFR 1.97(c)

2. ☐ The Information Disclosure Statement submitted herewith is being filed after three months of the filing of a national application, or the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or after the mailing date of a first Office Action on the merits, whichever occurred last but before the mailing date of either:

1. a Final Action under 37 CFR 1.113, or
2. a Notice of Allowance under 37 CFR 1.311,

whichever occurs first.

Also submitted herewith is:

- ☐ a certification as specified in 37 CFR 1.97(e);

OR

- ☐ the fee set forth in 37 CFR 1.17(p) for submission of an Information Disclosure Statement under 37 CFR 1.97(c).

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

P-25,096 USA

Application Number

09/856384
PCT/PTO 21 MAY 2001

Applicant(s)

Motegi et al.

Filing Date

Herewith

Group Art Unit

N/A

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	AL	10-172899	26.06.1998	Japan (English Abstract)	H01L	21/027		✓
	AM	62286226 A	12.12.1987	Japan (English Abstract)	H01L	21/30		✓
	AN	05-190427	30.07.1993	Japan (English Abstract)	H01L	21/027		✓
	AO	10-097990	14.04.1998	Japan (English Abstract)	H01L	21/027		✓
	AP							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.